Technical Specifications

Grid Table: ApoTome.2 generates optical sections of a defined thickness (in Rayleigh units, RU and microns, μm) depending on wavelength, microscope and objective used.

>	The	Advantages	

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> The Applications

> The System

> Technology and Details

> Service

> In Brief

Objectives for Axio Imager	V	NA	Immersion	Grid/Section thickness @490nm [RU/µm]			DAPI with	DAPI with
				High grid	Medium grid	Low grid	FS34	FS49
EC Plan-NEOFLUAR	10x	0.3	Air	2.9/31.9	1.7/18.2	0.9/9.9	Yes	Yes
EC Plan-NEOFLUAR	20x	0.5	Air	2.4/9.2	1.4/5.3	0.7/2.9	Yes	Yes
EC Plan-NEOFLUAR	40 x	0.75	Air	1.6/2.8	0.9/1.6	0.5/0.9	Yes	Yes
EC Plan-NEOFLUAR	40 x	1.3	Oil	2.5/2.2	1.4/1.2	0.8/0.7	Yes	Yes
EC Plan-NEOFLUAR	63 x	0.95	Air	1.0/1.1	0.6/0.7	0.4/0.4	Yes	No
EC Plan-NEOFLUAR	63 x	1.25	Oil	1.6/1.5	0.9/0.9	0.5/0.5	Yes	Yes
EC Plan-NEOFLUAR	100 x	1.3	Oil	1.0/0.9	0.6/0.5	0.4/0.3	Yes	Yes
LCI Plan-NEOFLUAR	25 x	0.8	Oil, water or glycerin	2.9/6.6	1.7/3.7	0.9/2.0	Yes	Yes
LCI Plan-NEOFLUAR	63 x	1.3	Water or glycerin	1.5/1.3	0.9/0.7	0.5/0.4	Yes	Yes
Plan-APOCHROMAT	10x	0.45	Air	4.2/20.4	2.4/11.5	1.3/6.2	Yes	Yes
Plan-APOCHROMAT	20 x	0.8	Air	3.2/4.9	1.8/2.8	1.0/1.5	Yes	Yes
Plan-APOCHROMAT	40 x	0.95	Air	1.6/1.7	0.9/1.0	0.5/0.5	Yes	Yes
Plan-APOCHROMAT	40 x	1.3	Oil	2.5/2.2	1.4/1.2	0.8/0.7	Yes	Yes
Plan-APOCHROMAT	40 x	1.4	Oil	2.4/1.8	1.4/1.0	0.7/0.6	Yes	Yes
Plan-APOCHROMAT	63 x	1.4	Oil	1.6/1.2	0.9/0.7	0.5/0.4	Yes	Yes
Plan-APOCHROMAT	100 x	1.4	Oil	1.0/0.8	0.6/0.5	0.4/0.3	Yes	Yes
LD LCI Plan-APOCHROMAT	25 x	0.8	Oil, water or glycerin	2.9/6.6	1.7/3.7	0.9/2.0	Yes	Yes
C-APOCHROMAT	10x	0.45	Water	4.2/20.4	2.4/11.5	1.3/6.2	Yes	Yes
C-APOCHROMAT	40 x	1.2	Water	2.2/2.0	1.2/1.1	0.7/0.6	Yes	Yes
C-APOCHROMAT	63 x	1.2	Water	1.4/1.3	0.8/0.7	0.5/0.4	Yes	Yes
LD C-APOCHROMAT	40 x	1.1	Water	2.2/2.3	1.2/1.3	0.7/0.7	Yes	Yes
Plan-APOCHROMAT	63 x	1.46	Oil	1.5/1.0	0.9/0.6	0.5/0.3	Yes	Yes
Plan-FLUAR	100 x	1.45	Oil	1.0/0.7	0.6/0.4	0.3/0.2	No	No
Plan-APOCHROMAT	100 x	1.46	Oil	1.0/0.7	0.6/0.4	0.3/0.2	Yes	No

Technical Specifications

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> The Advantages

> The Applications

> The System

> Technology and Details

Service

Objectives for Axio Imager	V	NA	Immersion	Grid/Section	thickness @490nm	[RU/µm]	DAPI with	DAPI with
				High grid	Medium grid	Low grid	FS34	FS49
EC Plan-NEOFLUAR	10 x	0.3	Air	2.9/31.5	1.7/18.5	0.9/9.8	Yes	Yes
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EC Plan-NEOFLUAR	40 x	0.75	Air	1.6/2.7	0.9/1.6	0.5/0.9	Yes	No
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EC Plan-NEOFLUAR	63 x	0.95	Air	1.0/1.1	0.6/0.7	0.4/0.4	Yes	Yes
EC Plan-NEOFLUAR	63 x	1.25	Oil	1.6/1.5	0.9/0.9	0.5/0.5	Yes	No
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LCI Plan-NEOFLUAR	25 x	0.8	Oil, water or glycerin	2.9/6.5	1.7/3.8	0.9/2.0	Yes	Yes
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Plan-APOCHROMAT	20 x	0.8	Air	3.1/4.8	1.8/2.8	1.0/1.5	Yes	Yes
Plan-APOCHROMAT	40 x	0.95	Air	1.6/1.7	0.9/1.0	0.5/0.5	Yes	Yes
Plan-APOCHROMAT	40 x	1.3	Oil	2.4/2.2	1.4/1.3	0.8/0.7	Yes	Yes
Plan-APOCHROMAT	40 x	1.4	Oil	2.4/1.8	1.4/1.1	0.7/0.6	Yes	Yes
Plan-APOCHROMAT	63 x	1.4	Oil	1.5/1.2	0.9/0.7	0.5/0.4	Yes	Yes
Plan-APOCHROMAT	100 x	1.4	Oil	1.0/0.8	0.6/0.5	0.4/0.3	Yes	No
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C-APOCHROMAT	63 x	1.2	Water	1.4/1.3	0.8/0.7	0.5/0.4	Yes	Yes
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Plan-APOCHROMAT	100 x	1.46	Oil	1.0/0.7	0.6/0.4	0.3/0.2	Yes	No

Technical Specifications

>	In Brief
>	The Advantages
>	The Applications
>	The System
>	Technology and Details
>	Service

	(Width x Depth x Height)
ApoTome.2 slider for Axio Imager	Approx. 278 mm x 90 mm x 76 mm
ApoTome.2 slider for Axio Observer/Axiovert 200	Approx. 295 mm x 90 mm x 78 mm
Control box ApoTome.2	Approx. 255 mm x 220 mm x 96 mm
Operating Data	
Protection Class, Protection Type	I, IP 20
Electrical Safety	According to DIN EN 61010-1 (IEC 61010-1) taking account of CSA and UL regulations
Overvoltage Category	
Interference Suppression	In accordance with EN 55011 class B
Interference Resistance	In accordance with DIN EN 61326-1
Supply Voltage	100 to 240 V \pm 10%. No Adjustment of the supply voltage is required
Supply Frequency	50 to 60 Hz
Power Consumption ApoTome.2	Max. 50 VA
Fuses in Accordance with IEC 127	
Control box ApoTome.2	2 A delayed-action/H/250 V, 5 x 20 mm
Control box Apotonicia	
Grid Frequencies	
·	5/9/17,5 lp/mm

The grid projection method used for the ApoTome.2 is sensitive to vibration, which can have various causes (including strong draughts). Vibrations are visible as streak artefacts in the resulting image. The microscope must therefore be set up so that it is exposed to as little vibration as possible on a vibration-damped table or on a suitable microscope base.





Count on Service in the True Sense of the Word

- > In Brief
- > The Advantages
- > The Applications
- > The System
- > Technology and Details
- > Service

Because the ZEISS microscope system is one of your most important tools, we make sure it is always ready to perform. What's more, we'll see to it that you are employing all the options that get the best from your microscope. You can choose from a range of service products, each delivered by highly qualified ZEISS specialists who will support you long beyond the purchase of your system. Our aim is to enable you to experience those special moments that inspire your work.

Repair. Maintain. Optimize.

Attain maximum uptime with your microscope. A ZEISS Protect Service Agreement lets you budget for operating costs, all the while reducing costly downtime and achieving the best results through the improved performance of your system. Choose from service agreements designed to give you a range of options and control levels. We'll work with you to select the service program that addresses your system needs and usage requirements, in line with your organization's standard practices.

Our service on-demand also brings you distinct advantages. ZEISS service staff will analyze issues at hand and resolve them – whether using remote maintenance software or working on site.

Enhance Your Microscope System.

Your ZEISS microscope system is designed for a variety of updates: open interfaces allow you to maintain a high technological level at all times. As a result you'll work more efficiently now, while extending the productive lifetime of your microscope as new update possibilities come on stream.







Profit from the optimized performance of your microscope system with services from ZEISS – now and for years to come.

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The moment your data change scientific minds.

This is the moment we work for.

- > In Brief
- > The Advantages
- The Applications
- > The System
- > Technology and Details
- > Service











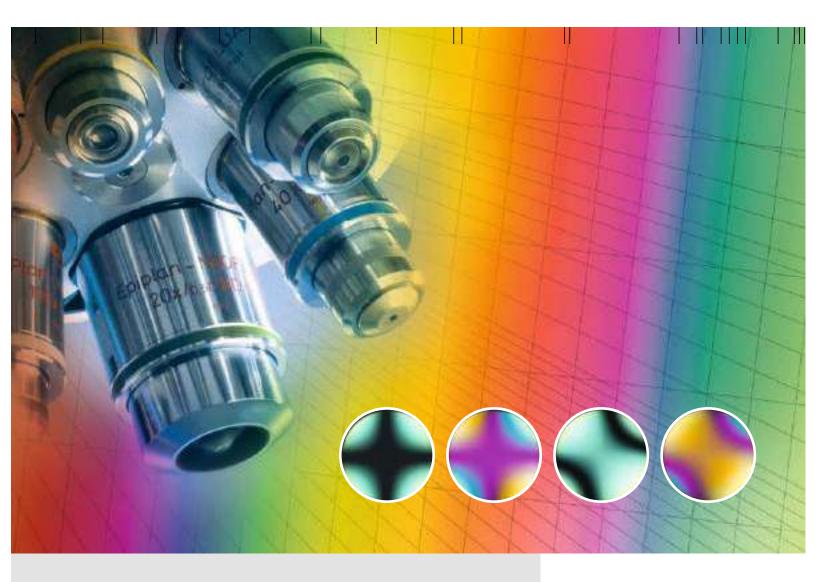






Michel-Lévy Color Chart

Identification of minerals in polarized light



Information on Polarization Microscopy

